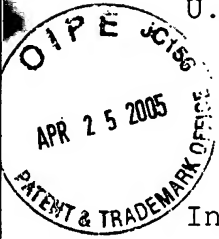


IFu

U.S.S.N. 10/728,967



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of:

Da-Wen Lin

Group Art Unit: 2815

Serial No.: 10/728,967

Examiner: Fenty, Jesse A.

Filed: Dec. 4, 2003

In Response to Office Action
Dated: March 22, 2005

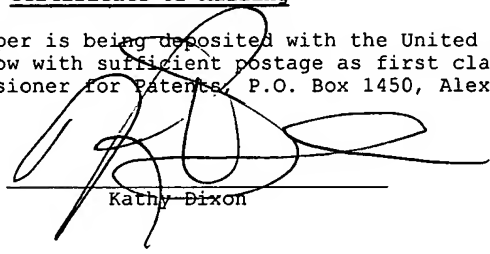
For: Recessed Gate Structure with Reduced Current
Leakage Overlap Capacitance

Attorney Docket No.: 67,200-1184

Certificate of Mailing

I hereby certify that this paper is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: Apr. 24, 2005


Kathy Dixon

RESPONSE TO OFFICE ACTION

Commissioner for Patents
Alexandria, VA 22313-1450

Dear Sir:

In response to an Office Action mailed March 22, 2005 of a restriction requirement imposed by the Examiner, the Applicants hereby elect with traverse the prosecution of Group I, method claims 1-14 and 26.